TELEFUNKEN Semiconductors

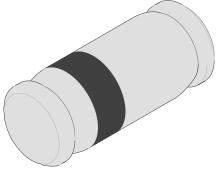
Silicon Epitaxial Planar Diodes

Features

• Electrical data identical with the devices 1N4148 and 1N4448 respectively

Applications

Extreme fast switches



94 9371

Absolute Maximum Ratings

 $T_j = 25^{\circ}C$

Parameter	Test Conditions	Туре	Symbol	Value	Unit
Repetitive peak reverse voltage			V_{RRM}	100	V
Reverse voltage			V_{R}	75	V
Peak forward surge current	t _p =1μs		I_{FSM}	2	A
Repetitive peak forward current			I_{FRM}	450	mA
Forward current			I _F	200	mA
Average forward current	$V_R=0$		I _{FAV}	150	mA
Power dissipation			P_{V}	500	mW
Junction temperature			Tj	175	°C
Storage temperature range			T _{stg}	<i>−</i> 65+175	°C

Maximum Thermal Resistance

 $T_j = 25^{\circ}C$

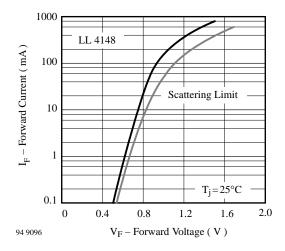
Parameter	Test Conditions	Symbol	Value	Unit
Junction ambient	on PC board 50mmx50mmx16mm	R _{thJA}	500	K/W

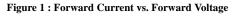
Characteristics

 $T_i = 25^{\circ}C$

Parameter	Test Conditions	Type	Symbol	Min	Тур	Max	Unit
Forward voltage	I _F =5mA	LL4448	V_{F}	0.62		0.72	V
_	I _F =50mA	LL4148	V_{F}		0.86	1	V
	I _F =100mA	LL4448	$V_{\rm F}$		0.93	1	V
Reverse current	V _R =20 V		I_R			25	nA
	$V_R = 20 \text{ V}, T_j = 150 ^{\circ}\text{C}$		I_R			50	μΑ
	$V_R=75 V$		I_R			5	μΑ
Breakdown voltage	$I_R=100\mu A, t_p/T=0.01, t_p=0.3ms$		V _(BR)	100			V
Diode capacitance	V _R =0, f=1MHz, V _{HF} =50mV		C_{D}			4	pF
Rectification efficiency	V _{HF} =2V, f=100MHz		$\eta_{ m r}$	45			%
Reverse recovery time	$I_F=I_R=10$ mA, $i_R=1$ mA		t _{rr}			8	ns
			t _{rr}			4	ns

Typical Characteristics $(T_j = 25^{\circ}C \text{ unless otherwise specified})$





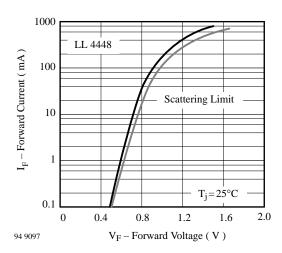
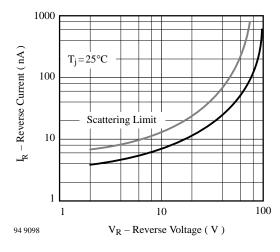
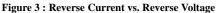


Figure 2: Forward Current vs. Forward Voltage

TEMIC

TELEFUNKEN Semiconductors





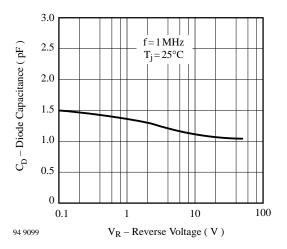
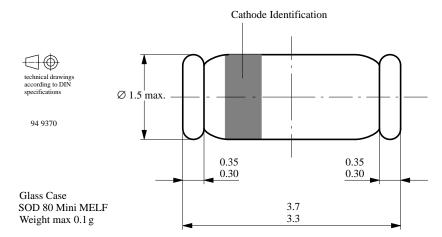


Figure 4: Diode Capacitance vs. Reverse Voltage

Dimensions in mm



TEMIC

TELEFUNKEN Semiconductors

OZONE DEPLETING SUBSTANCES POLICY STATEMENT

It is the policy of TEMIC TELEFUNKEN microelectronic GmbH to

- 1. Meet all present and future national and international statutory requirements and
- 2. Regularly and continuously improve the performance of our products, processes, distribution and operating systems with respect to their impact on the health and safety of our employees and the public, as well as their impact on the environment.

Of particular concern is the control or elimination of releases into the atmosphere of those substances which are known as ozone depleting substances (ODSs).

The Montreal Protocol (1987) and its London Amendments (1990) will soon severely restrict the use of ODSs and forbid their use within the next ten years. Various national and international initiatives are pressing for an earlier ban on these substances.

TEMIC TELEFUNKEN microelectronic GmbH semiconductor division has been able to use its policy of continuous improvements to eliminate the use of any ODSs listed in the following documents.

- 1. Annex A, B and list of transitional substances of the Montreal Protocol and the London Amendments respectively
- 2. Class I and II ozone depleting substances in the Clean Air Act Amendments of 1990 by the Environmental Protection Agency (EPA) in the USA and
- 3. Council Decision 88/540/EEC and 91/690/EEC Annex A, B and C (transitional substances) respectively.

TEMIC can certify that our semiconductors are not manufactured with and do not contain ozone depleting substances.

We reserve the right to make changes to improve technical design without further notice.

Parameters can vary in different applications. All operating parameters must be validated for each customer application by the customer. Should the buyer use TEMIC products for any unintended or unauthorized application, the buyer shall indemnify TEMIC against all claims, costs, damages, and expenses, arising out of, directly or indirectly, any claim of personal damage, injury or death associated with such unintended or unauthorized use.

TEMIC TELEFUNKEN microelectronic GmbH, P.O.B. 3535, D-74025 Heilbronn, Germany Telephone: 49 (0)7131 67 2831, Fax Number: 49 (0)7131 67 2423